

# Data collection Strategy

**SLAC** NATIONAL ACCELERATOR LABORATORY



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- Before .....
  - Geometry, detectors, resolution...
  - Data collection strategy.
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# Science

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# What is the scientific question?

## How will probing the structure help?

- Is there an alternative method?
  - TEM
  - EXAFS
  - Neutron diffraction
  - BET porosity measurements
- Can data from a sealed tube diffractometer give at least part of the answer?

If answer to either of the question above is even a hesitant yes.

## Do those measurements first

- They will help you do a better and easier synchrotron experiment.
- They will complement your synchrotron data and will simplify data analysis and interpretation.

- Structure completely unknown
  - Single Crystal
  - Polycrystalline → Rietveld method
  - Disordered → PDF
- Partially known
  - Site occupancy → full pattern refinement, AXS/REXS
- Interested in noncrystallographic features
  - Particle size → peak shape analysis
  - Texture → 2D diffraction
  - Strain → 2D diffraction, Q space resolution

- Impulse driven
    - Phase transition
    - Strain
  - Time Dependent
    - Chemical Reaction
    - Relaxation processes
  - In-situ rigs and reactors: **Doug**
    - Laser pump-probe
  - Will the scattering from the reactor windows interfere?
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# Sample

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# What does the sample look like?

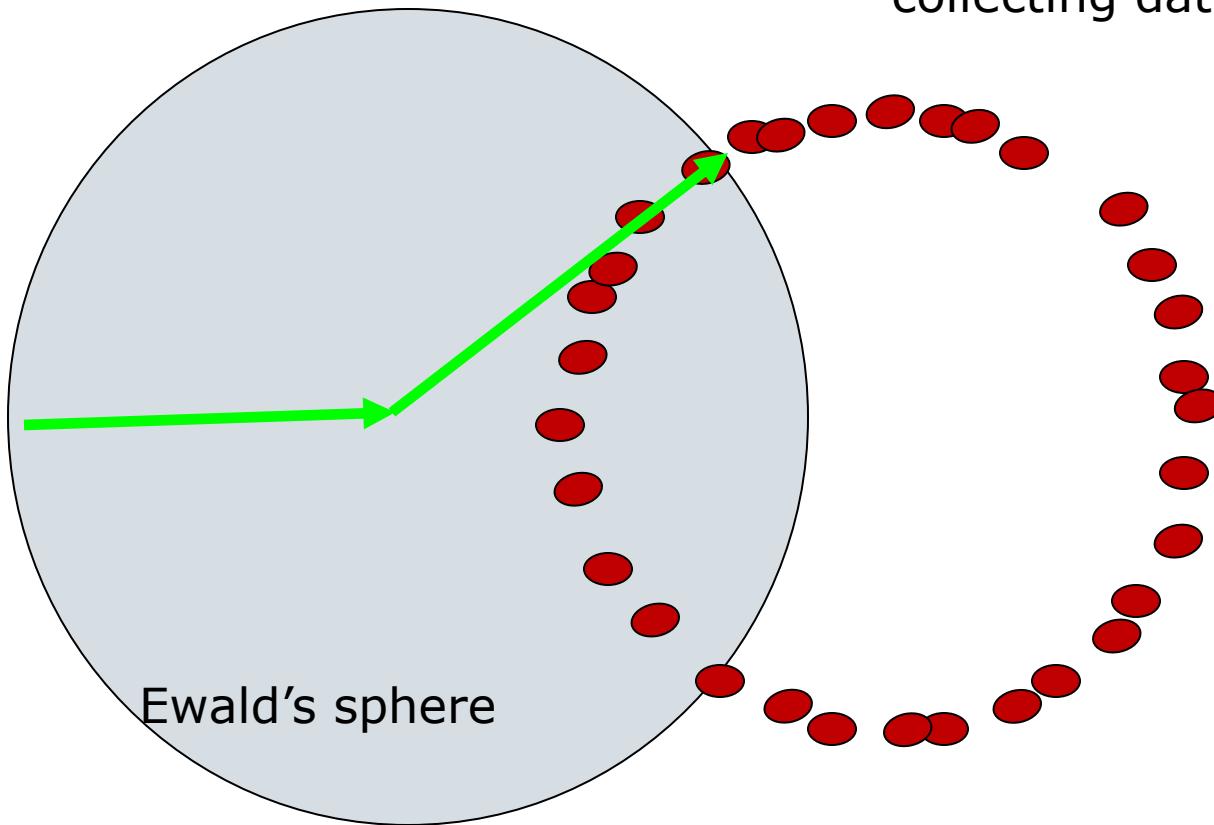


- Bulk
  - powder or solid/pressed pellet
  - Would preferred orientation matter?
    - finely grind AND spin if possible
- Transmission or Reflection:
  - Refl → blocks bottom half of the pattern
  - Refl sample should be infinitely thick if possible
  - Trans samples are ideally  $\sim \mu$
- Wet?
- Does it need containment window?



# Powder Average and Rocking

Oscillate while  
collecting data

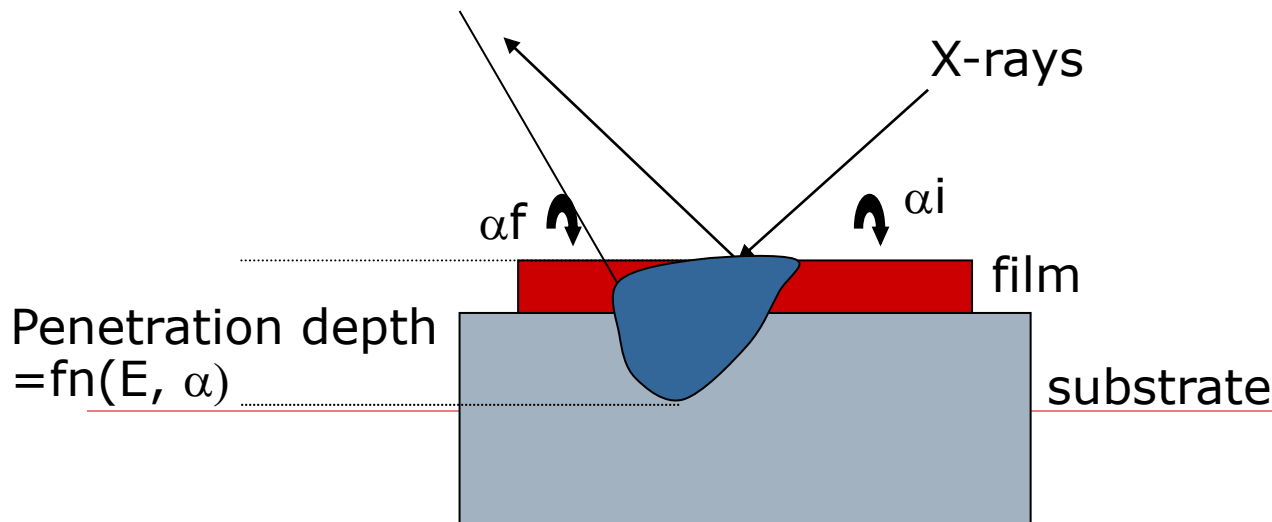


Ewald's sphere

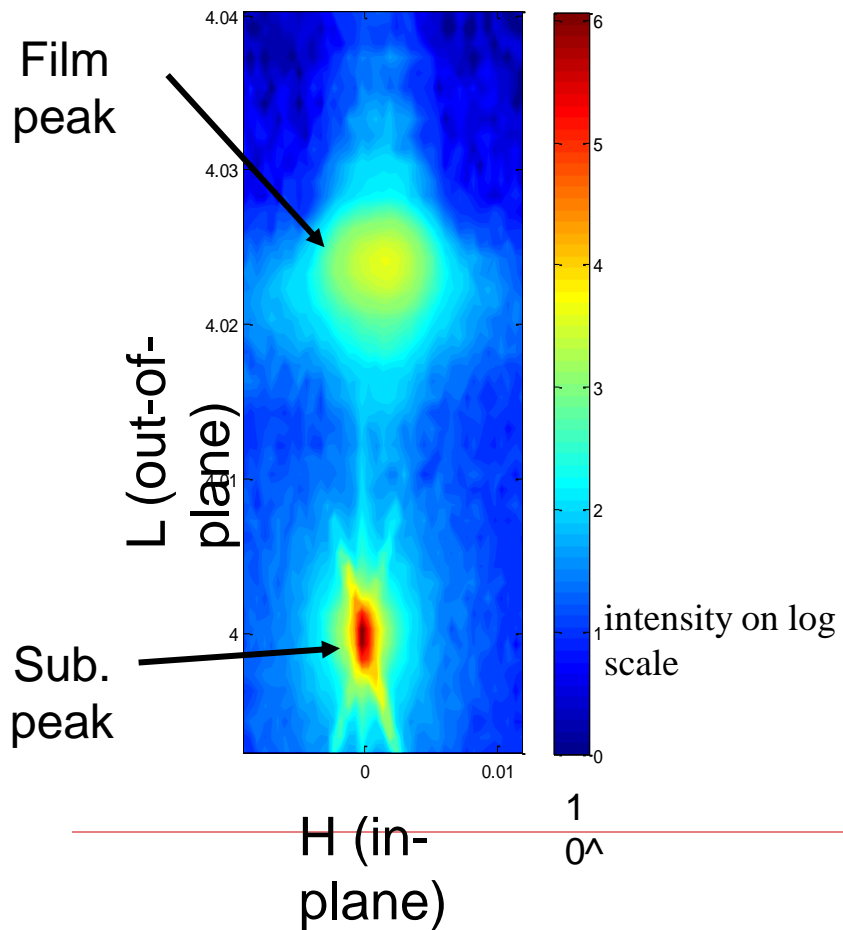
# What Does the Sample look like?

## □ Thin Film

- Will the scattering from the substrate interfere?
  - Weak – as it is not in diffracting condition (e.g., single crystal substrates)
  - Can it be avoided by placement of the detector?
    - harder with an area detector

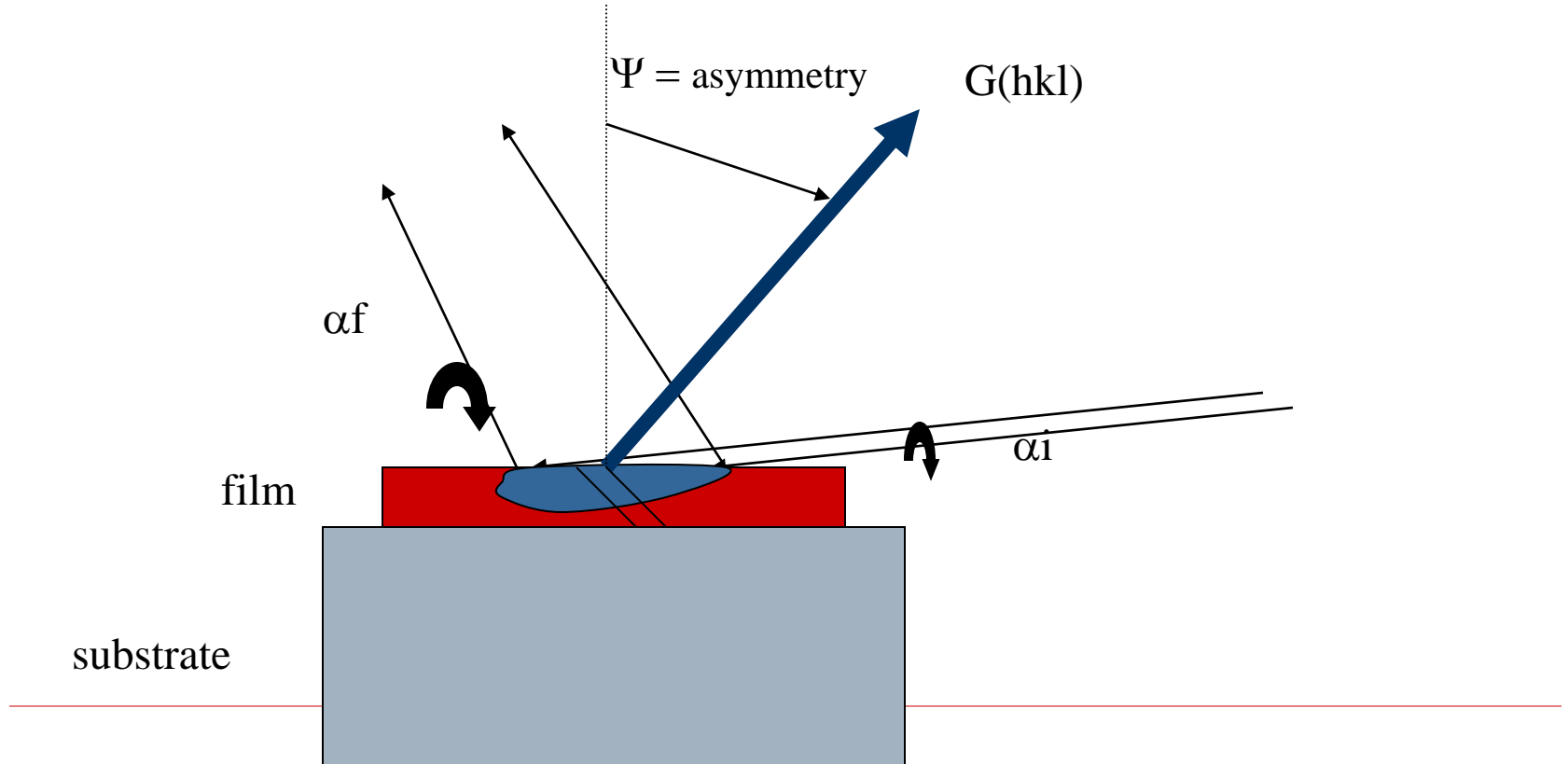


# Thin Film



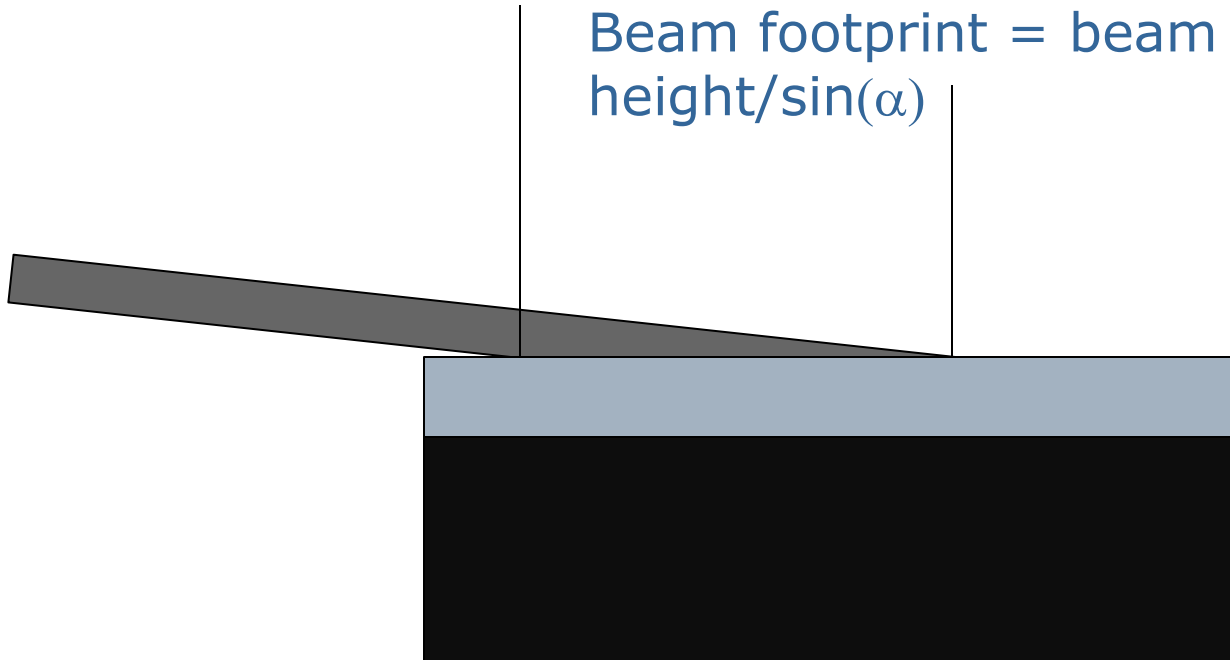
# Thin Film: Substrate interferences

## Grazing Incidence Geometry



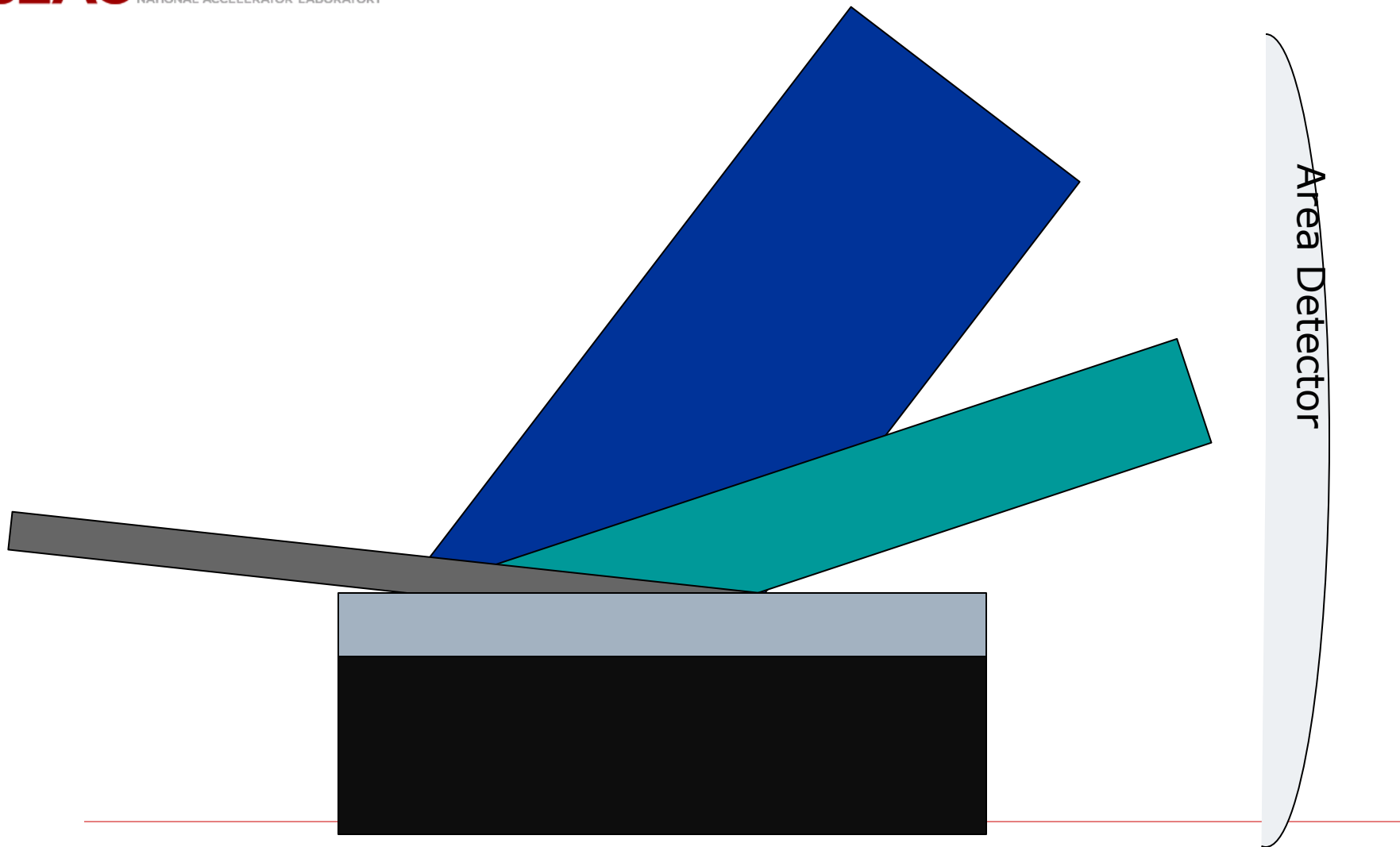
# Grazing Incidence : Beam footprint

Beam footprint = beam  
height/ $\sin(\alpha)$



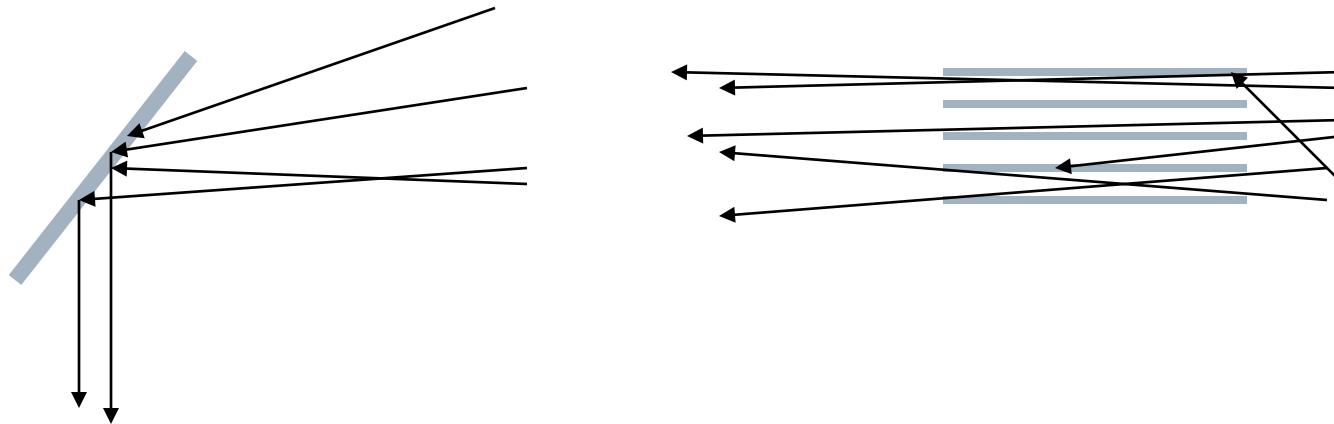
$\alpha \sim 0.5^\circ$ ,  
for a 100 micron beam  $\rightarrow$  beam footprint  $\sim 10$  mm  
GIXRD requires long ( $\sim 20$  mm) and flat samples

# Grazing Incidence: Peak widths

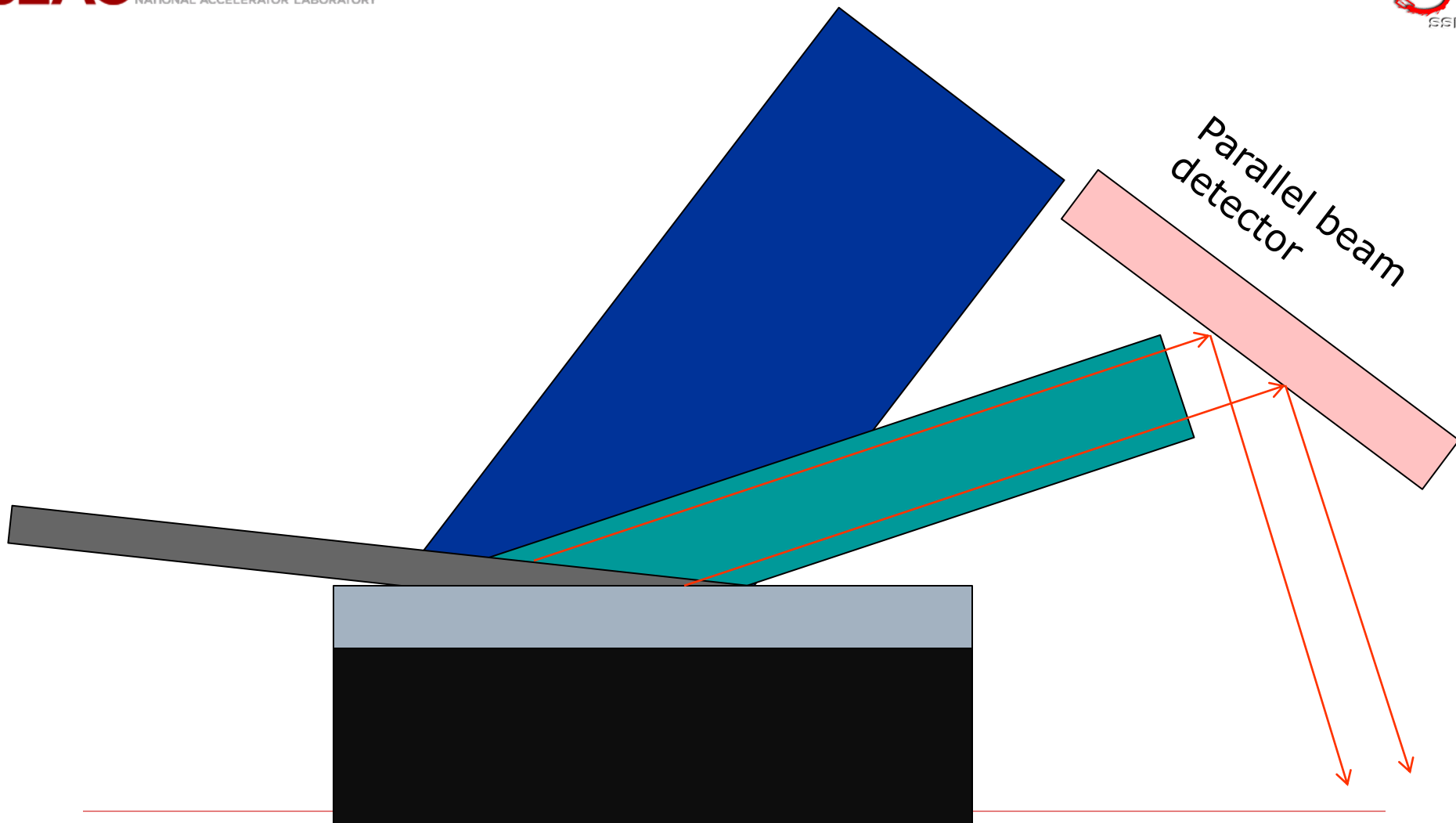


# Parallel beam detection

- Crystal Analyzer
- Soller Slits
- Perfect crystal (Si or Ge)



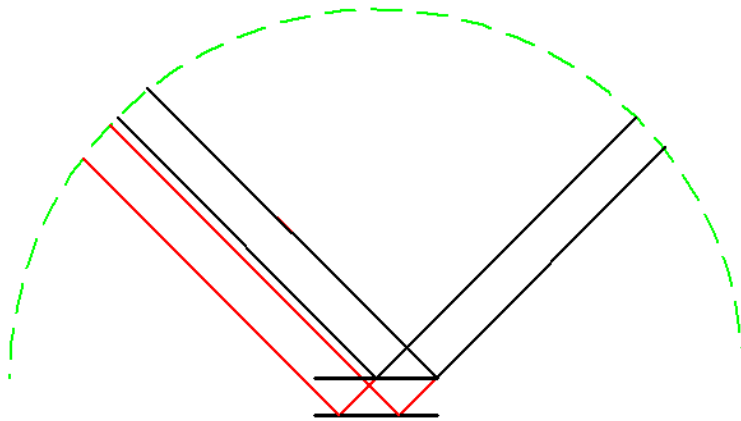
# Grazing Incidence: Peak widths





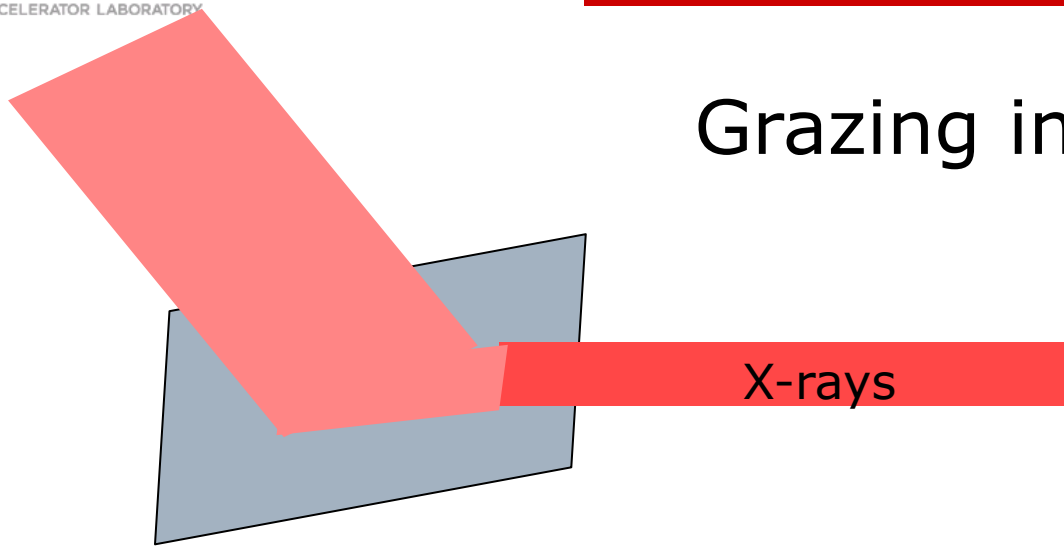
# Parallel Beam Detection:

Misalignment Tolerant

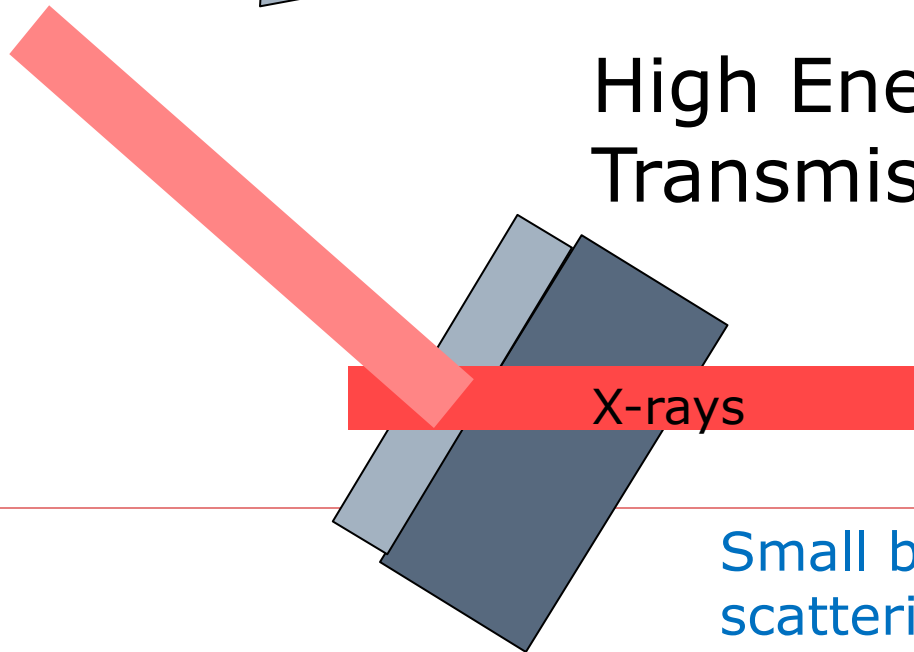


# Thin Film: inplane peak

Grazing incidence



High Energy Transmission



>16 keV : x-rays  
can easily penetrate  
300 micron Si or  
Sapphire substrate

Small beam footprint, easier  
scattering geometry

# Detectors

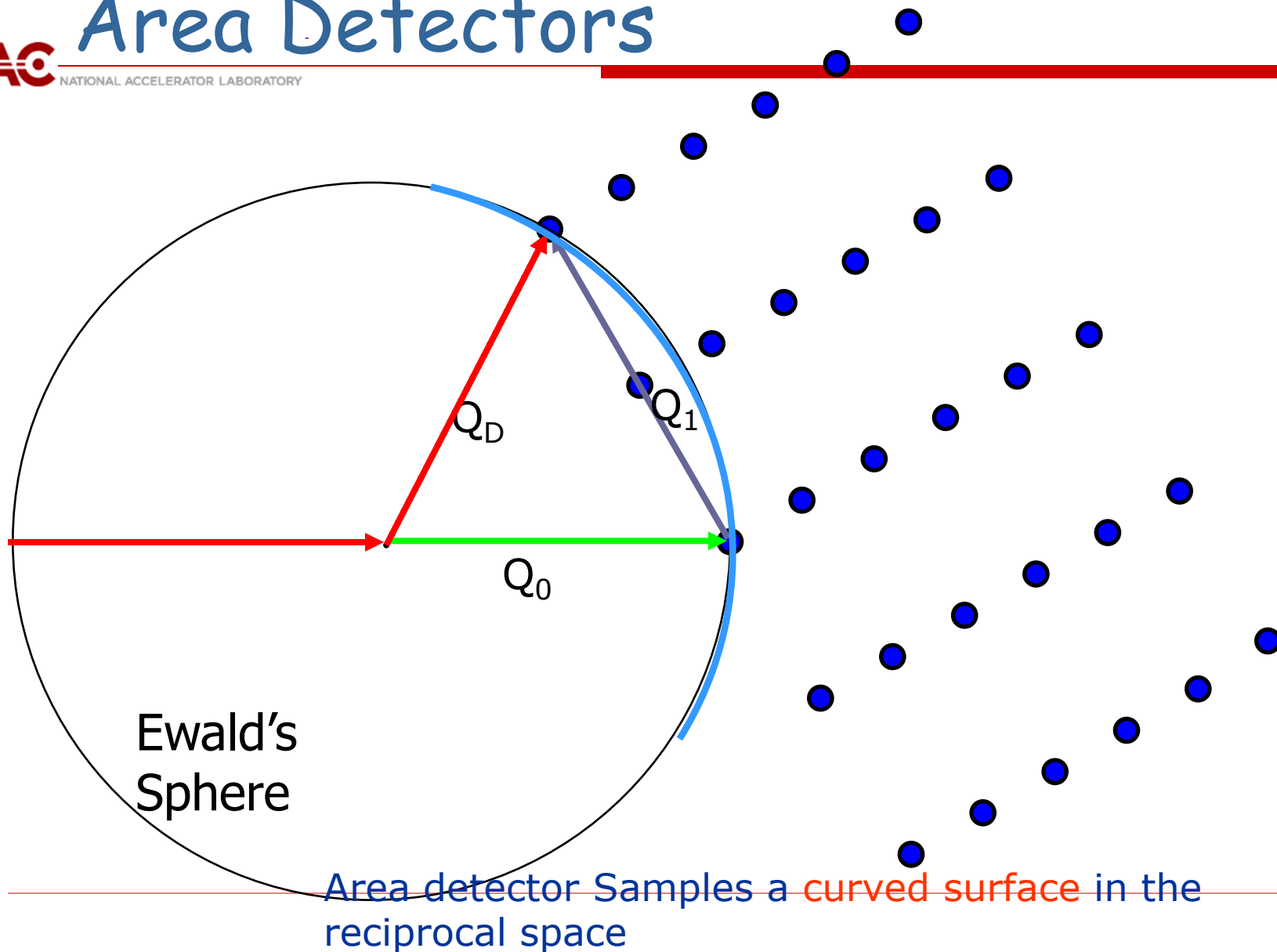
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# Detectors



- Point Detectors:** data collection sequential
  - Can be used in parallel beam geometry
  - By using attenuators → very large dynamic range
  - low noise, single photon counting
  - Energy Sensitive detectors: E resolution  $\sim 200$  eV
    - Vortex, Ge detector
    - Good when there is need to remove inelastic scattering signal: e.g., fluorescence, compton scattering
  - Energy Insensitive detectors: E resol  $> 1000$  eV
    - photomultiplier, avalanche photodiode

# Area Detectors



Area detector Samples a curved surface in the reciprocal space

- **Area Detectors** : parallel data collection.
    - Cannot be easily used in parallel beam geometry
    - Dynamic range usually 8 bit (60K), but improving
    - noise higher, but improving
    - No energy resolution, but can have a low E threshold
- 
- MAR345, PI CCD, Pilatus

Can you use

- Area detector for lower resolution, quick measurements?
  
  - High resolution point detector for details?
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# Optimal scan range and resolution

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# Instrumental Resolution & peak width

$$W_m^2 = W_s^2 + W_i^2$$

Measured sample instrumental

OK for nanocrystals

Ideally  $W_i < 0.5 W_s$

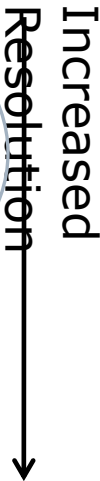
But not too small as improvement in instrumental resolution comes at the cost of intensity

Area Detector

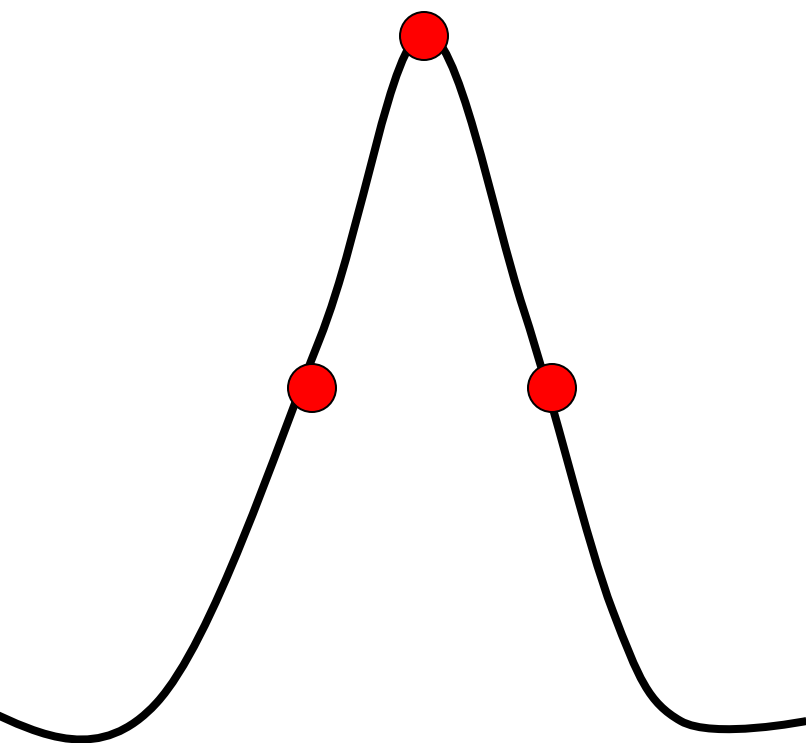
1mRad Soller Slits

Crystal Analyzer

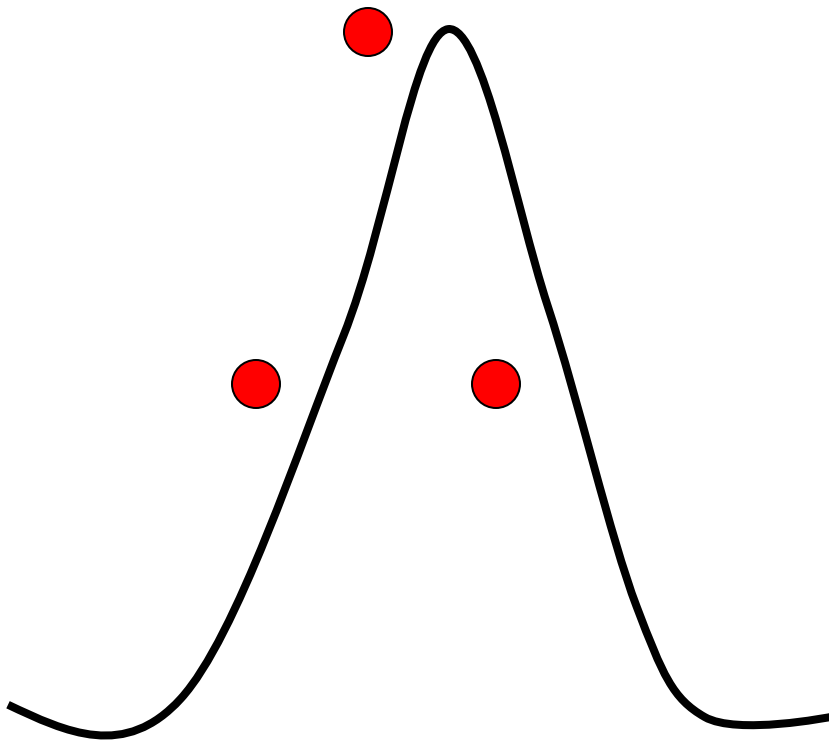
Resolution Increased



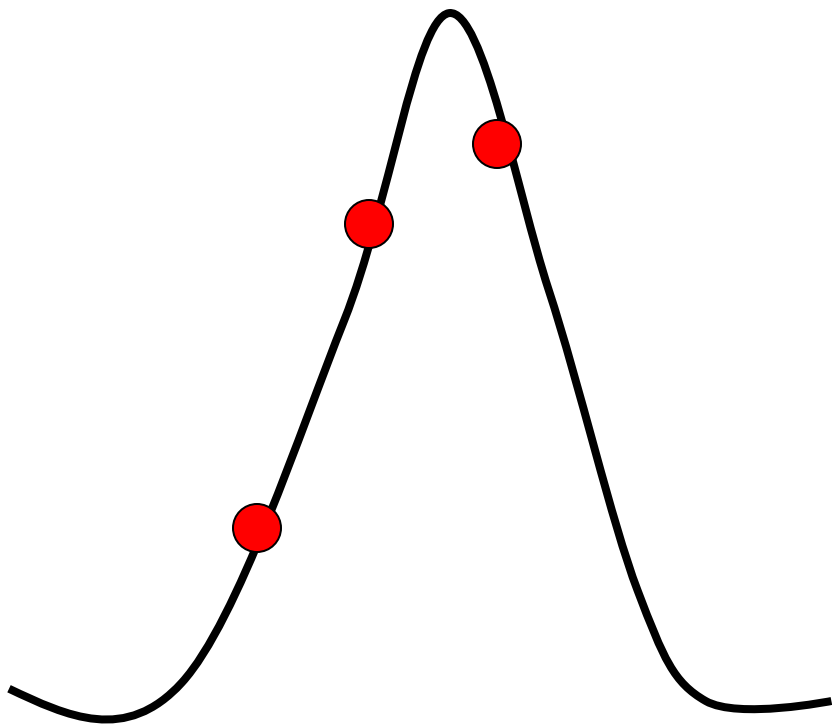
Step Size



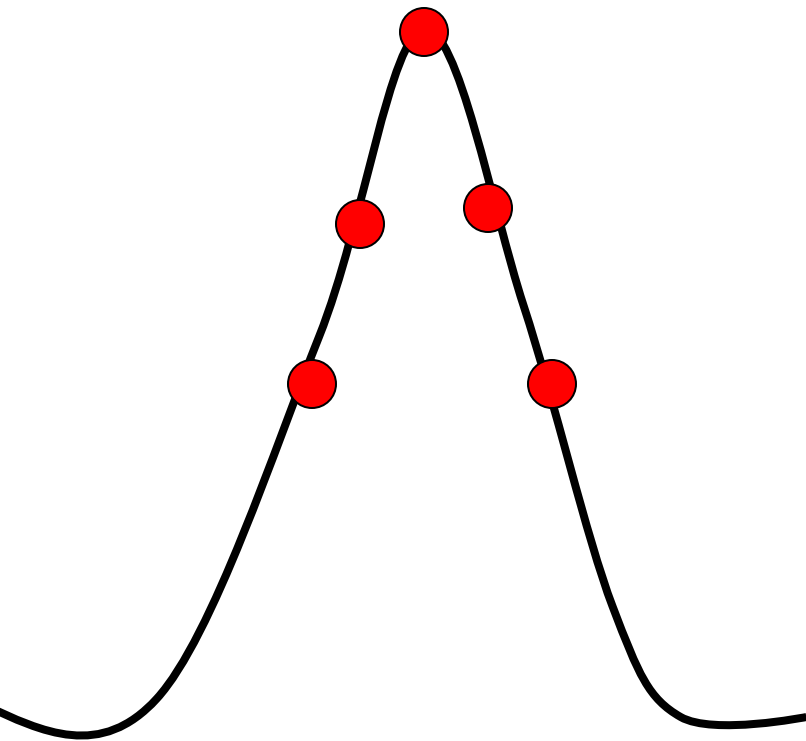
Step Size



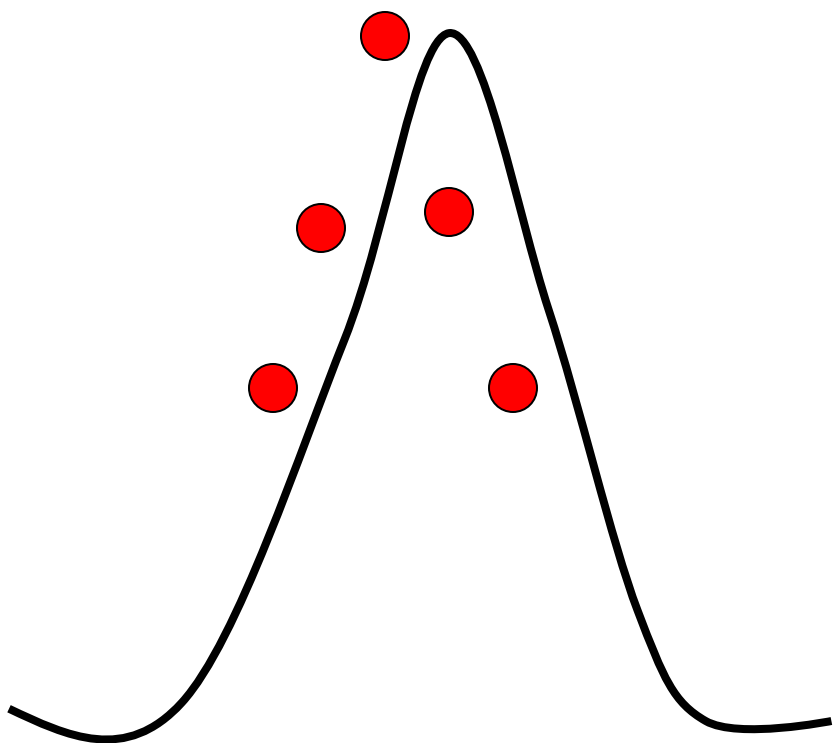
Step Size



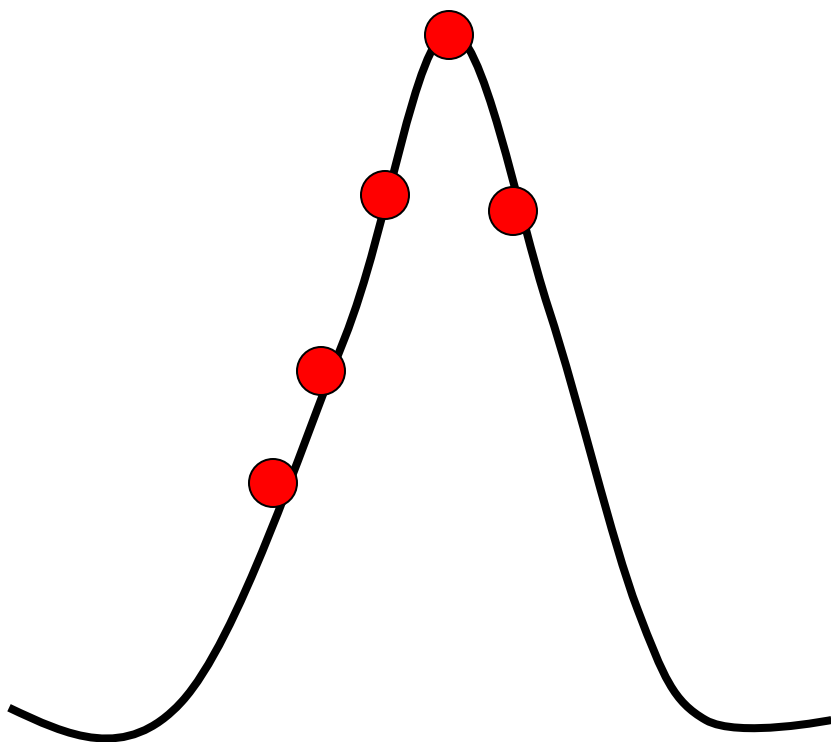
Step Size



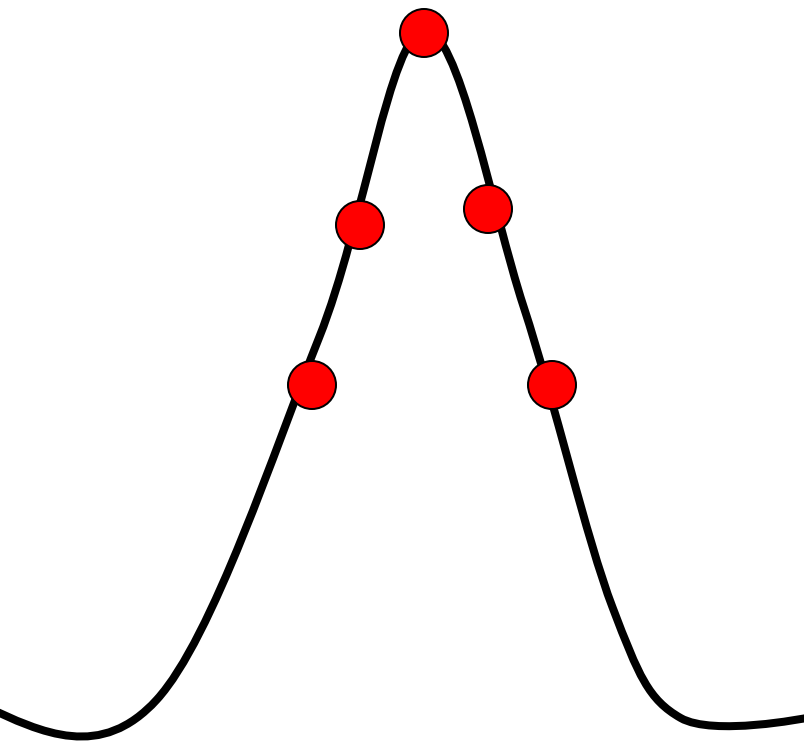
Step Size



Step Size



## Step Size



Minimum of 5 points in FWHM

But probably not more than 10

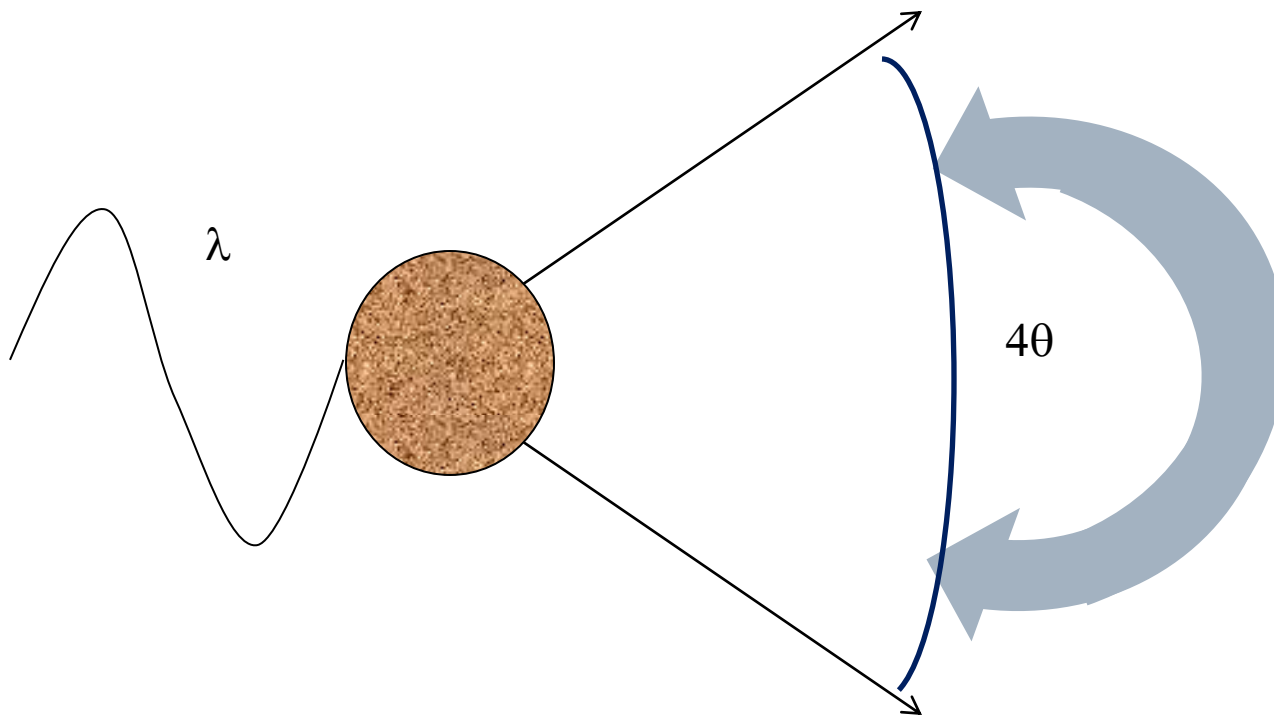
Keep the dwell time so that  
Each Sweep is not too long  
 $\sim 2 - 6$  hr.

If better statistic reqd  
Repeat sweeps and add.

- Averages out some of the time dependent drifts
- If unexpected beam dumps still have usable data
- Allows better control on statistics



# Diffraction Pattern



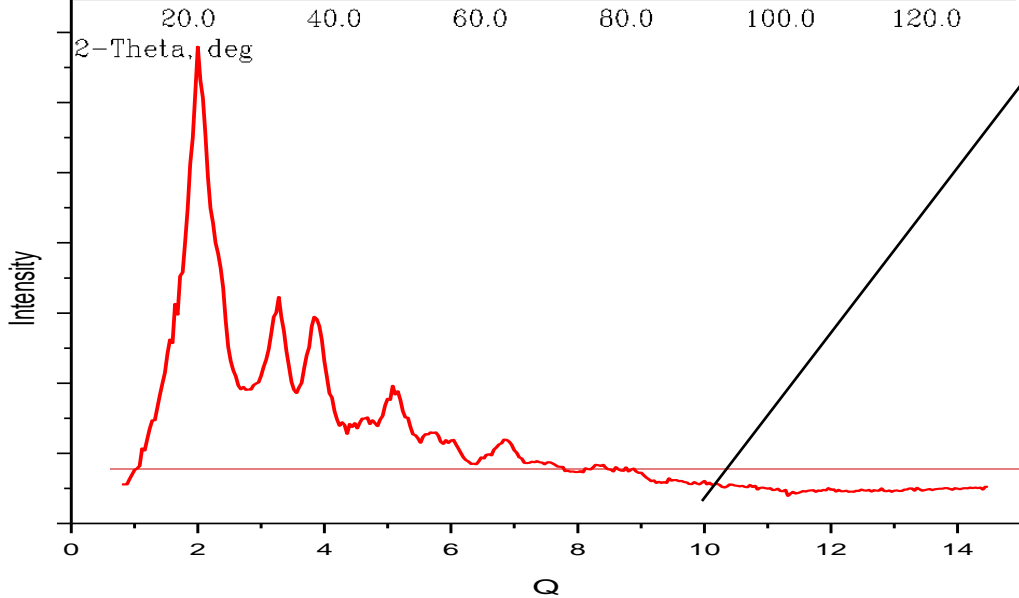
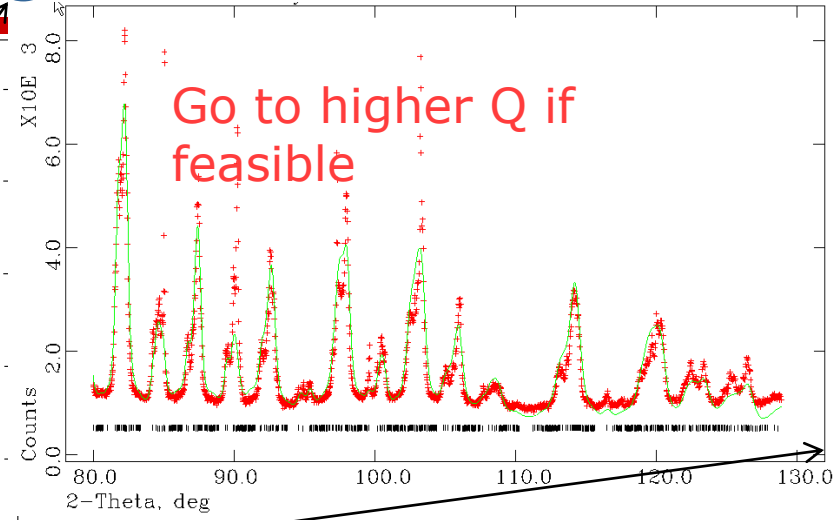
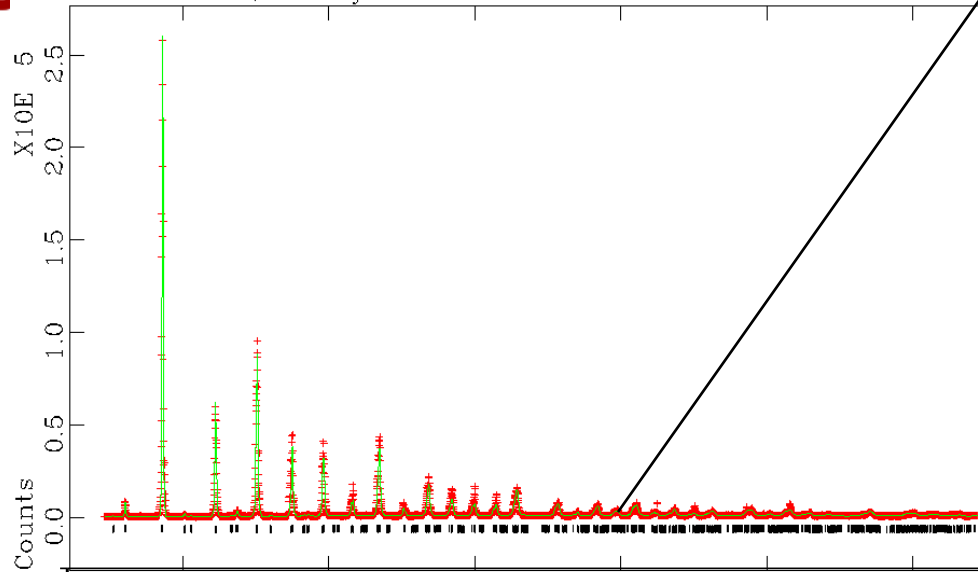
Diffraction Pattern:

Contains all the contrast relevant information at the resolution of

$$\lambda/2\sin(\theta) \sim 2\pi/Q_{\max}$$

$$Q = 4\pi \sin(\theta) E/hc$$

# Best use of time



# Data Collection Strategy



- Before the experiment
  - Q Range
  - Q resolution
  - X-ray Energy
    - Fluo bkg, Resonance scattering
  - Diffractometer and sample geometry –
    - 2 circle, 4 circle, GI, transmission
  - Detectors
- During Data collection
  - Scan parameters (step size, dwell time.)
  - Beam damage?
    - Dehydrate, photo- redox, reacts with the environment

Thanks

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